



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 31, 2026	
IGI Report Number	LG822609767
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PEAR MODIFIED BRILLIANT
Measurements	10.90 X 6.54 X 4.50 MM

GRADING RESULTS

Carat Weight	2.45 CARATS
Color Grade	FANCY YELLOW
Clarity Grade	VS 1

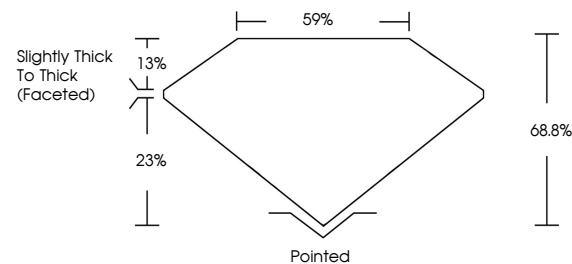
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG822609767

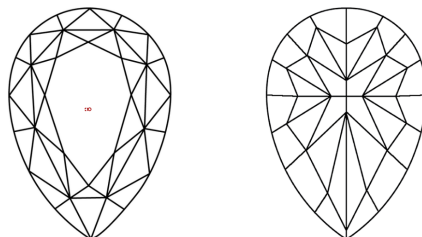
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG822609767
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

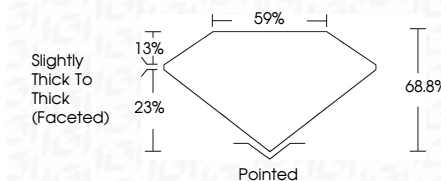
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www.igi.org

July 31, 2026
GI Report No LG822609767
WEAR MODIFIED BRILLIANT

MM	2.45 CARATS	VS 1	68.8%	59%	Pointed	EXCELLENT	EXCELLENT	NONE
	FANCY YELLOW				Slightly Thick To Thick (Faceted)			

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition